

ITW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2825

Examiner: Caridad M. Everhart

In Re PATENT APPLICATION OF:

Applicant: Minoru Watanabe

Serial No.: 10/829,450

Filed: April 22, 2004

For: METHOD OF FORMING A RESIST
PATTERN AND FABRICATING
TAPERED FEATURES

Attny Ref.: MAE 311

AMENDMENT

November 23, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Official Action mailed on August 23, 2004. No fee is due. However, please charge our Deposit Account No. 18-0002 if any fees are needed to enter this paper, and please advise us accordingly. It is noted that no petition is required because of the authorization to charge, but please consider this paper a petition for extension of time if needed.

FEE ENCLOSED:\$
Please charge any further
fee to our Deposit Account
No. 18-0002